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APPLICANTS

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**** C/PING DATA *******

This application is a 371 of PCT/JP03/02568 03/05/2003

**** FOREIGN APPLICATIONS *******

JAPAN 2002-261286 09/06/2002
 JAPAN 2002-059182 03/05/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>F.H.</i>				

ADDRESS

00909

TITLE

Process for producing silicon single crystal layer and silicon single crystal layer

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